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Response Under 37 CFR § 1.116
Expedited Procedure - Group 1755

03500.017562.

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

MAKOTO KUBOTA, ET AL.

Application No.: 10/665,429

Filed: September 22, 2003

For: COMPOSITION FOR
FORMING PIEZOELECTRIC
FILM, MANUFACTURING
METHOD OF
PIEZOELECTRIC FILM,
PIEZOELECTRIC ELEMENT
AND INK JET RECORDING
HEAD

Examiner: C. Koslow

Group Art Unit: 1755

June 29, 2005

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL REJECTION

Sir:

In response to the final Office Action dated March 29, 2005, please amend
the above-identified application as follows:

I hereby certify that this correspondence is being deposited with the
United States Postal Service as first-class mail in an envelope addressed
to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-
1450 on

June 29, 2005

(Date of Deposit)

Damond E. Vadnais, Reg. No. 52,310

(Name of Attorney for Applicant)


Signature

June 29, 2005
Date of Signature